

Atty. Docket: 97-CCP-251 DIV

Serial No.: (not yet assigned)

List of Documents

Cited by Applicant

(Use several sheets if necessary)

Applicant: Eric GERRITSEN, et al.

Filing Date: HEREWITH

Group: (not yet assigned)

JUL 11 2003

U.S. PATENT DOCUMENTS

Ex'rs	Document Number	Date	Name	Class	Sub-class	Filing Date, if applicable
AA1	5,545,574	8/13/96	CHEN et al.			
AA2	5,659,194	8/19/97	IWAMATSU et al.			
AA3	4,821,085	4/1989	Haken et al.			
AA4	4,849,802	7/1989	Jackson et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub-class	Transl'n Yes/No
AA5	0 746 012 A2	12/4/96	Europe		
AA6	0123456 A2	01/2000	Europe		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AA7	European Patent Abstract of Japanese Publication No. 05218069, published on August 27, 1993
AA8	"Advances in the formation of C54-TiSi2 with an interposed refractory metal layer: some properties", Microelectronic Engineering, vol. 37-38, November 1997, pages 449-454.
AA9	"Resistivity and morphology of TiSi2 formed on Xe+ implanted polycrystalline silicon", Applied Physics Letters, vol. 56, no. 5 January 12, 1990, pages 440-442.
AB1	European Search Report dated December 3, 1998 with annex on French Application No. 9803134.

Examiner:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.